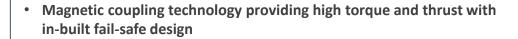
Deposition

- Designed for deposition applications such as MBE, sputtering and CVD
- Alternative applications include substrate annealing, degassing and other high temperature material modifications
- Substrate heating to 1,200°C
- Continuous substrate rotation
- Homing for automatic transfer alignment



Motion and Manipulation

- Devices for all types of motion down to UHV levels of vacuum (10⁻¹²)
- · Providing: X, Y, Z motion, rotation, tilt and combinations of these
- Custom solutions available



Bellows sealed actuators with demountable bellows for servicing



Surface Science

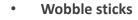
- Analytical stages with multiple parking positions
- Up to 5 axes of motion with sample biasing
- Sample cooling to <30K with LHe and LN2 precooling
- Sample heating to 1,200°C



Typically used in:

- Analytical instruments
- Surface analysis equipment
- Synchrotron end stations





Transfer arms

Bespoke complex designs



Sample Transfer

- Suitable for industry standard, flags, pucks and wafers
- A range of flange sizes and stroke lengths
- Motorisation or manual actuation
- Customisation available

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